



ELECTRONIC COPY

LG660405200
Report verification at igi.org



October 16, 2024
IGI Report Number **LG660405200**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **EMERALD CUT**
Measurements **8.57 X 5.87 X 3.84 MM**
GRADING RESULTS
Carat Weight **2.00 CARATS**
Color Grade **E**
Clarity Grade **VS 1**

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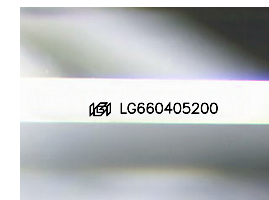
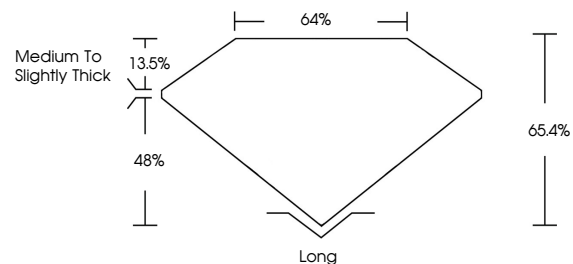
Carat Weight **2.00 CARATS**
Color Grade **E**
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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG660405200**

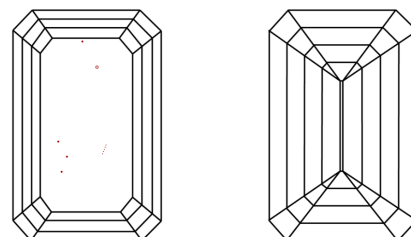
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

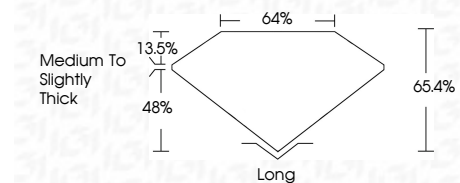
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| | | | | |
|---------------------|-----------------------------|------------------------|-------------------|------------------|
| IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
| Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI

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IGI Report No. **LG660405200**
EMERALD CUT
Carat Weight **2.00 CARATS**
Color Grade **E**
Clarity Grade **VS 1**
Table **64%**
Depth **48%**
Girdle **Medium to Slightly Thick**
Culet **Long**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG660405200**

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